



Attorney Docket No. 0756-7176

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koji DAIRIKI

Serial No. 10/625,737

Filed: July 24, 2003

For: SEMICONDUCTOR DEVICE

MANUFACTURING METHOD, HEAT

TREATMENT APPARATUS, AND

HEAT TREATMENT METHOD

) Group Art Unit: 2822

) Examiner: Maria F. Guerrero

) CERTIFICATE OF MAILING

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) Adeline M. Stamps

AMENDMENT

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated June 14, 2006, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.

Entered  
W/KCE  
12/07/06  
W.M.  
12/22/06